

# FEE TRANSMITTAL

Electronic Version 1.1.0

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Large Entity

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## SUBMITTED BY

Authorized Name: Margaret Chappuis

Electronic Signature Mark: Margaret Chappuis

Date Signed: 20021001

## BASIC FILING FEE

Fee Description	Fee Code	Fee Paid
Utility Filing Fee	101	\$ 740

Subtotal For Basic Filing Fee: \$ 740

## EXTRA CLAIM FEES

	Fee Code	Fee	Extra Claims	Fee Paid
Total Claims: 44	103	\$ 18	24	\$ 432
Independent Claims: 7	102	\$ 84	4	\$ 336

Subtotal For Extra Claims Fees: \$ 768



# TRANSMITTAL FORM

Electronic Version 1.0.3

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Attorney Docket  
Number:

ATMI-  
466

Submission Type: Utility Patent  
Filing

## COMPOSITION AND CHEMICAL VAPOR DEPOSITION METHOD FOR FORMING ORGANIC LOW K DIELECTRIC FILMS

First Named Inventor: Mr. Neil H Hendricks

### SUBMITTED BY

Name:	Ms. Margaret Chappuis
Registration Number:	45,735
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### Attached Files:

specification	466spec.xml
bibd-transmittal	466subpapersapds.xml

fee-transmittal

466subpapersfee.xml

Comments:

Electronic Filing System (EFS) Data  
Electronic Patent Application Submission  
USPTO Use Only

EFS ID: 18468  
Application ID: 10065302  
Title of Invention: COMPOSITION AND CHEMICAL  
VAPOR DEPOSITION METHOD FOR  
FORMING ORGANIC LOW K  
DIELECTRIC FILMS  
First Named Inventor: Neil Hendricks  
Domestic/Foreign Application: Domestic Application  
Filing Date: null  
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